

FIGURE 2

FIG. 3

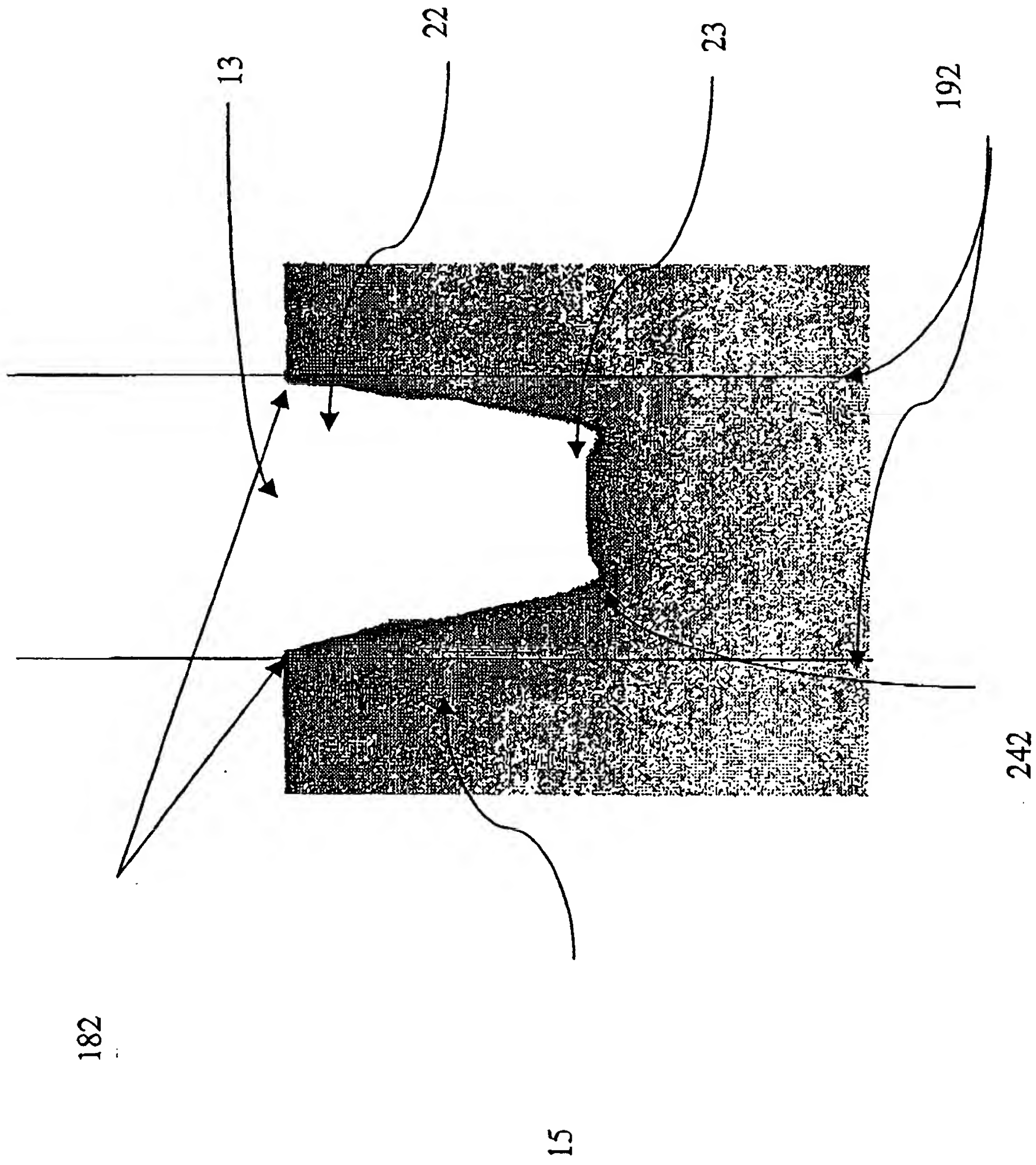


FIGURE 3

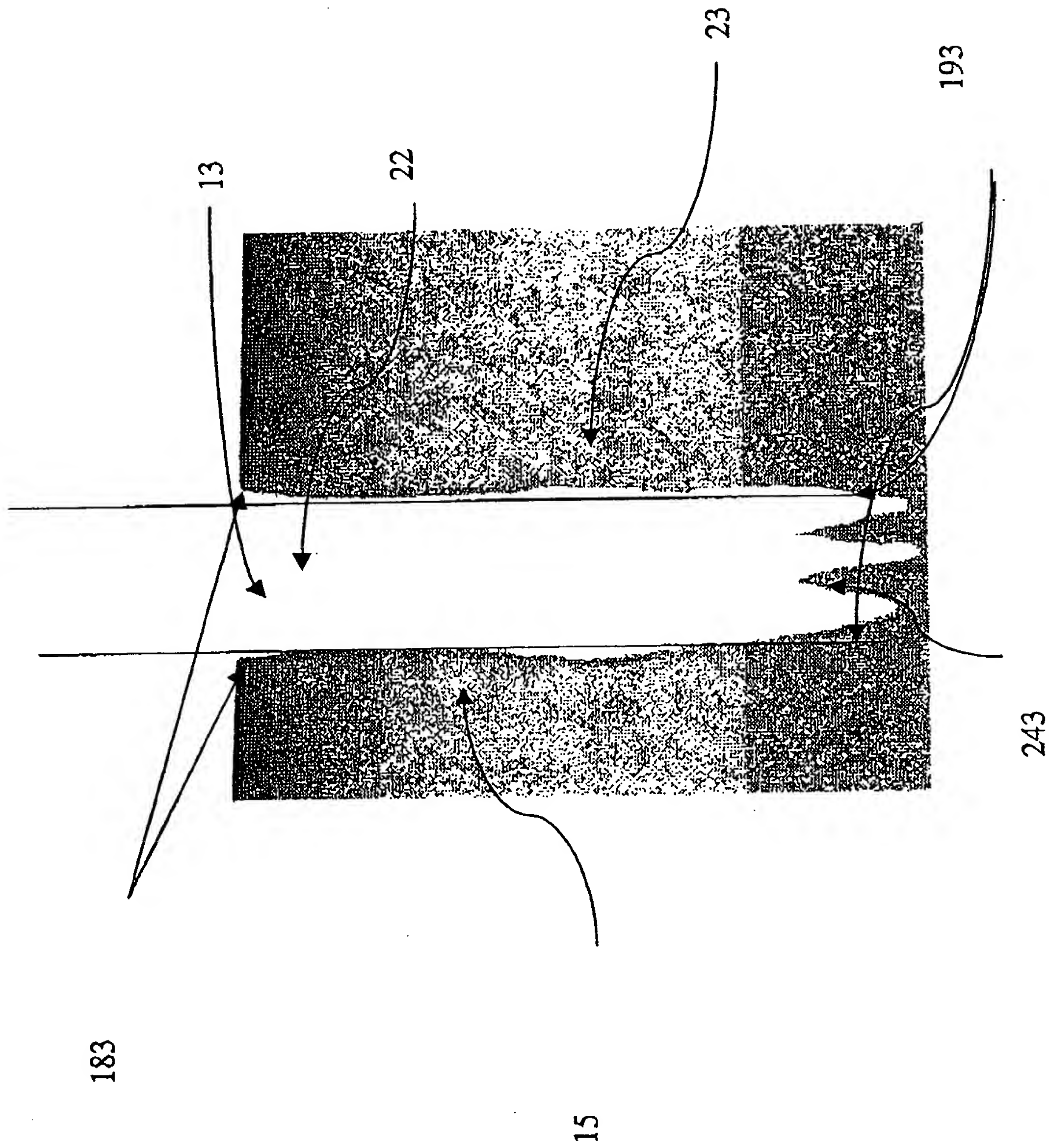


FIGURE 4

FIG. 5 is a schematic diagram of a system for processing a sample in a vacuum chamber. The system includes a vacuum chamber 400, a sample holder 402, a sample 404, a first RF source 406, a second RF source 414, a first RF electrode 408, a second RF electrode 408, a sample holder 410, a sample 412, and a turbo pump connection.

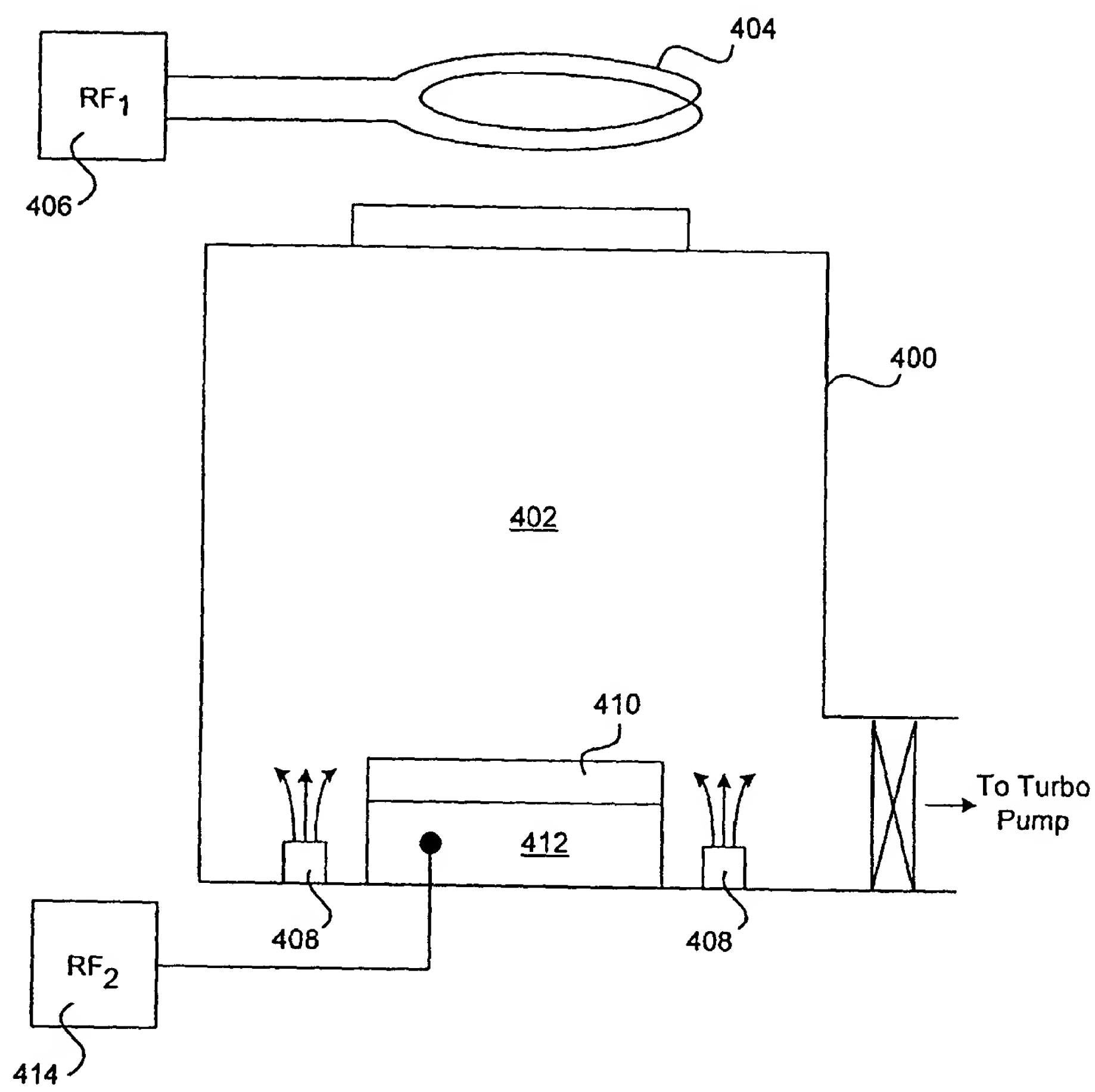


FIGURE 5

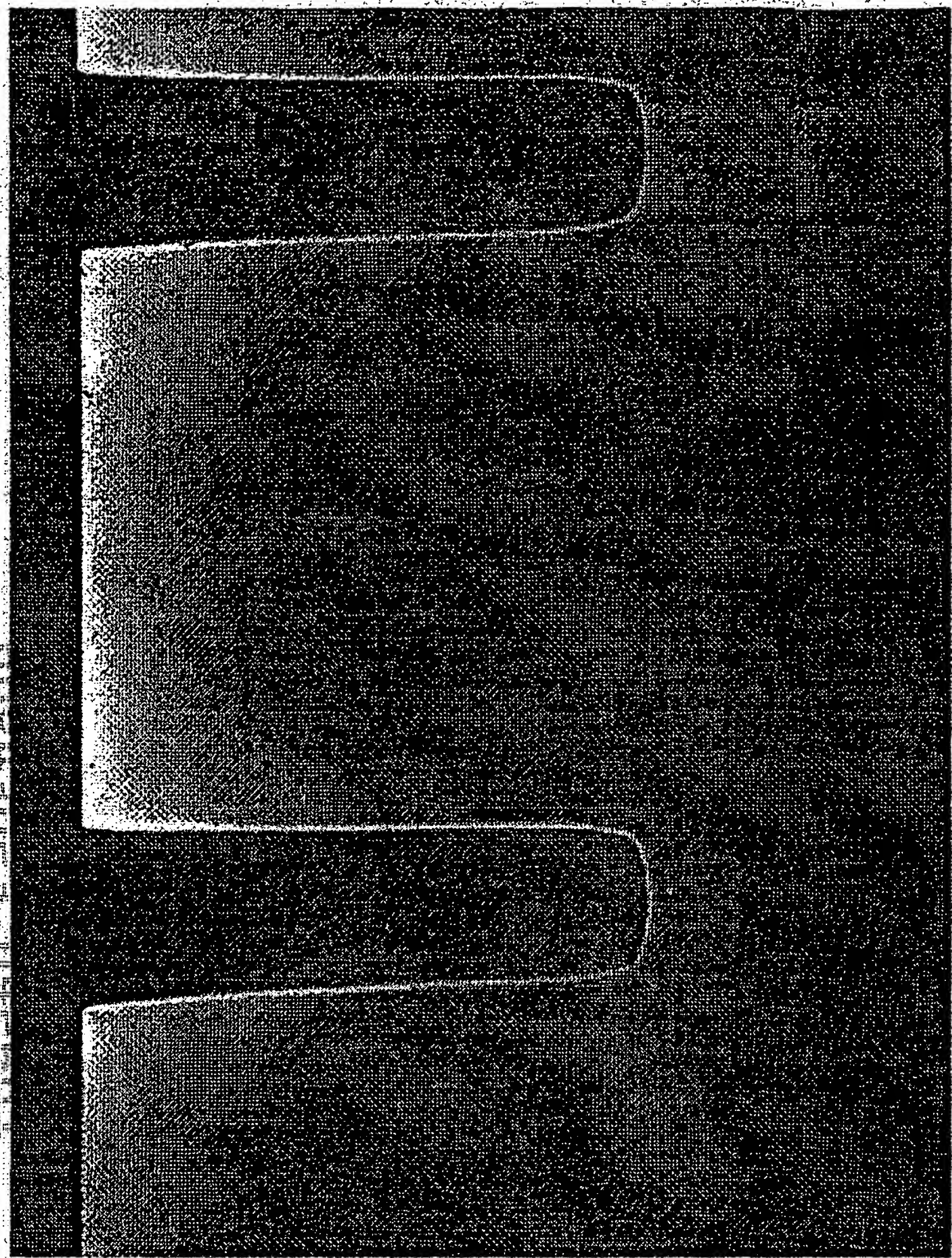


FIGURE 6

Top Corner
Rounding

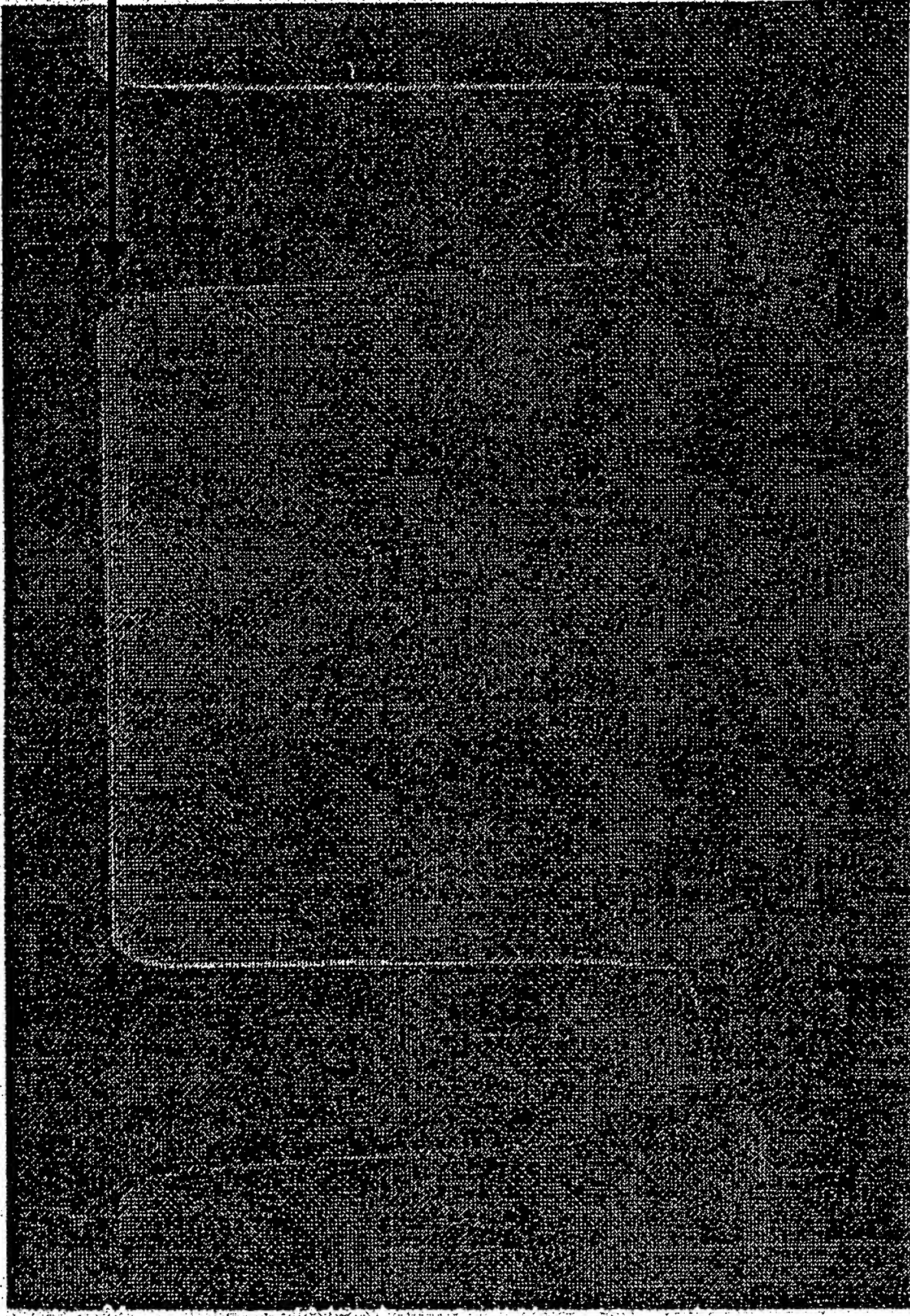


FIGURE 7